



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Allowed:

HAN et al.

Atty. Ref.: 4290-4; Confirmation No. 5867

Allowed: August 29, 2005

Appl. No. 10/690,665

TC/A.U. 1763

Filed: October 23, 2003

Examiner: G. Goudreau

For: METHOD FOR AVOIDING POLYSILICON FILM OVER ETCH ABNORMAL

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January 17, 2006

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

**AMENDMENT IN CONJUNCTION WITH RCE
AND PETITION TO REVIVE**

In conjunction with a concurrently filed RCE and Petition to Revive, applicants
now request reconsideration of this application and entry of the following amendment: